

Form PTO-1449
(SNL-Modified)
(9/94)

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(37 CFR 1.98(b))

ATTY. DOCKET NO.
SD6957S97604

SERIAL NO.
09 /

APPLICANT
Clews et al

FILING DATE

12/5/01

GROUP

11002 U.S. PRO
10/010850
12/05/01

U. S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE
BT	1	4,009,115	2/22/77	Binns	252	142	8/25/75
BT	2	4,370,173	1/25/83	Dollman	134	3	4/30/82
BT	3	4,959,105	9/25/90	Neidiffer	134	3	3/14/90
BT	4	5,824,601	10/20/98	Dao	438	713	6/30/97

FOREIGN PATENT OF PUBLISHED FOREIGN PATENT APPLICATION

		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

BT	1	J. Buhler, F.-P. Steiner and H. Baltes, "Silicon Dioxide Sacrificial Layer Etching in Surface Micromachining," <u>Journal of Micromechanics and Microengineering</u> , vol. 7, pp. R1 - R13, 1997.
BT	2	P.T.J. Gennissen and P.J. French, "Sacrificial Oxide Etching Compatible with Aluminum Metallization," <u>Proceedings of the 1997 International Conference on Solid-State Sensors and Actuators, Transducers '97</u> , pp. 225-228, 1997.
BT	3	J.F.L. Goosen, B.P. van Driehhuizen, P.J. French and R.F. Wolffenbuttel, "Problems of Sacrificial Etching in the Presence of Aluminum Interconnect," <u>Sensors and Actuators A</u> , vol. 62, pp. 692-697 (1997).

EXAMINER

Binh Tran

DATE CONSIDERED

2/7/03

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OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

BT	4	L. Archer and S.-A. Henry, "Removing Potash Polymer Residue from BEOL Structures Using Inorganic Chemicals," <u>Micro</u> (micromagazine.com), pp. 95-103, June 2001.
BT	5	"Reidel-de Haen Electronic Chemicals of Semiconductor Grade," (www.sigmaaldrich.com/saws.nsf/Pages/fl_newproducts_sp3?OpenDocument) pp. 1-4, November 28, 2001.

EXAMINER	Binh Tran	DATE CONSIDERED	2/7/03
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